

Application/Control No.	Applicant(s)/Patent under Reexamination
10/645,901	TSUCHIYA ET AL.
Examiner	Art Unit
Tianjie Chen	2627

SEARCHED					
Class	Subclass	Date	Examiner		
360	324.11				
	324.12	6/2/2006	TJ		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
360	324.12	6/2/2006	TJ	
	1-			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East reports	6/2/2006	TJ	